

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)
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MAEKAWA et al.	)
	)
Serial No.: 10/827,457	)
	)
Filed: April 19, 2004	)
	)
For: Method For Forming Pattern And	)
Drop Discharge Apparatus	)
	)
Examiner: Marianne L. Padgett	)
	)
Art Unit: 1762	)
	)
Confirm No.: 2984	)

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Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C (AFTER FINAL)**

Applicants have the following response to the Final Rejection of July 6, 2007.

Please amend the above-identified application as follows: